

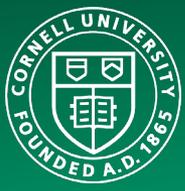


Cornell NanoScale Science & Technology Facility

NNCI ANNUAL CONFERENCE

Nov. 2-3, 2021

Chris Ober, Lester B. Knight Director
Claudia Fischbach-Teschl, Associate Director
Ron Olson, Director of Operations
Lynn Rathbun, Laboratory Manager



Prof. Christopher Ober
PI, Director

Prof. Claudia
Fischbach-Teschl,
Co-PI, Assoc. Director



Ron Olson
Director of Operations

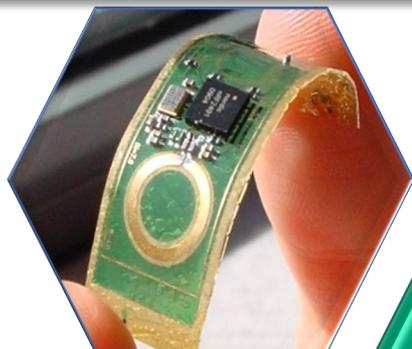
Lynn Rathbun, Ph.D.
Laboratory Manager



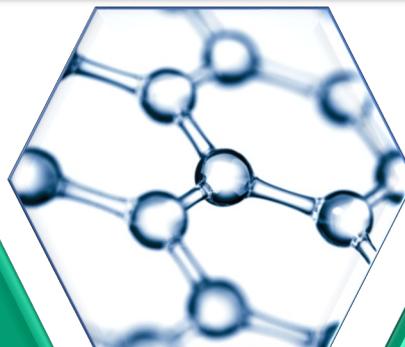
- We are a uniquely capable nanofabrication facility within NNCI
- Site of strong, active biology, physics, electrical engineering and materials research activities
- Educator of the next generation of interdisciplinary engineers and scientists
- Engine of economic development
- Provider to large external user community (~40%)
- >40 years of experience as a successful user facility focused on nanofabrication
 - New strategic directions and activities

Addressing NSF's 10 Big Ideas on Data Revolution, Quantum Leap, Convergence, Rules of Life, Future of Work, ...

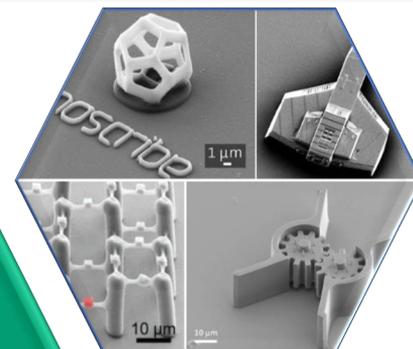
2



Life Sciences



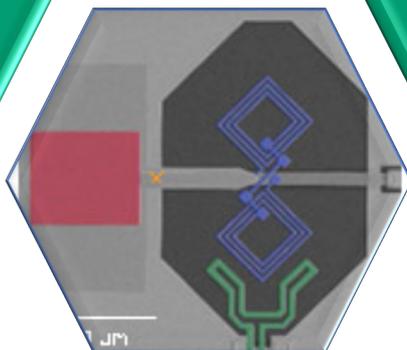
Hetero-
integration



3D Fabrication
and
Characterization

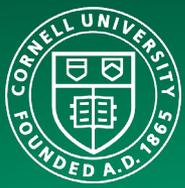
Quantum
Information
Devices

2D Materials



Research Communities:

- Understanding the Rules of Life
- Transform Quantum/Quantum Leap
- Nano-Enabled Internet of Things



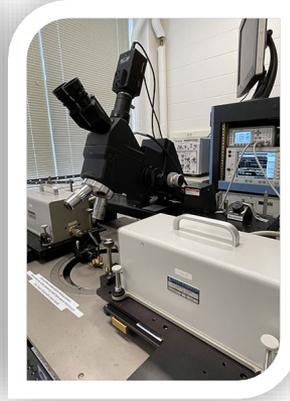
High Frequency Test Lab

Existing Equipment

- DC probe station and electronics
- Microwave probe station
- “Load Pull” RF test station

Applications:

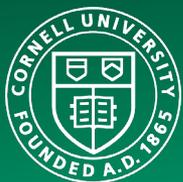
Heterointegration and Quantum Device Testing



MRI 2021- mm wave network analyzer

- Ultrawide band vector network analyzer
 - One of the first in the world
 - Single sweep DC to 220 GHz
- Automated Probe station
 - 1 μm precision
 - Thermal chuck





Cornell Visualization and Imaging Partnership (CVIP)

- CNF and the Cornell Institute of Biotechnology (Biotech) have partnered to create a shared Life Science characterization and imaging facility.
- CNF users will access a broad range of 3-D characterization tools including a variety of confocal microscopes, super-resolution microscopes, and micro/nano-xray-CT scanning.



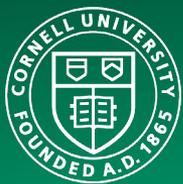
Cornell Multiscale 3D Fabrication Partnership (CM3FP)

- CNF has partnered with the Cornell Mechanical Engineering department's Rapid Prototyping Lab to make a broad range of 3-D printing technologies available to our users.
- CNF and RPL staff will act as a gateway to these new 3-D printers, providing consultation, software services, design help, billing, and user support.



Research Community

- Understanding the Rules of Life



Cornell Nanoscale Facility

- High purity materials deposition/etch
- New tools (e.g. atomic layer etch)
- Heterointegration and packaging



CCMR MRSEC

- Materials, Characterization and Theory
- World leading electron microscopy
- Quantum light sources and quantum sensing of materials



High Energy Synchrotron Source

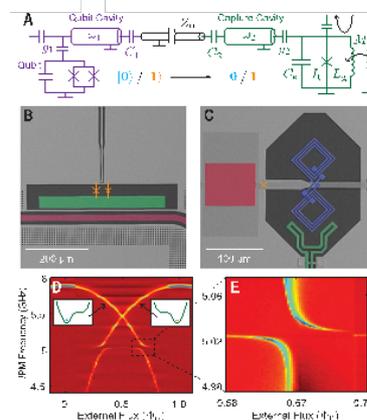
- High Magnetic Field (HMF) beamline
- Study quantum materials in persistent magnetic fields



2D Materials MIP

- New interface materials—that do not exist in nature

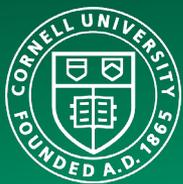
- CNF is a key part of a growing research ecosystem investigating quantum materials, quantum devices and quantum systems
- Provides nanofabrication, heterointegration and packaging while partnering with centers supporting quantum research



Global Quantum Leap
(AccelNet – a network of networks)

Research Community

- Transform Quantum/Quantum Leap



Center for Research on Programmable Plant Systems (CROPPS)

The CROPPS STC will generate a new paradigm for observing, recording, and modulating plant responses to their environment—the Internet of Living Things (IoLT).



A National Science Foundation Science & Technology Center

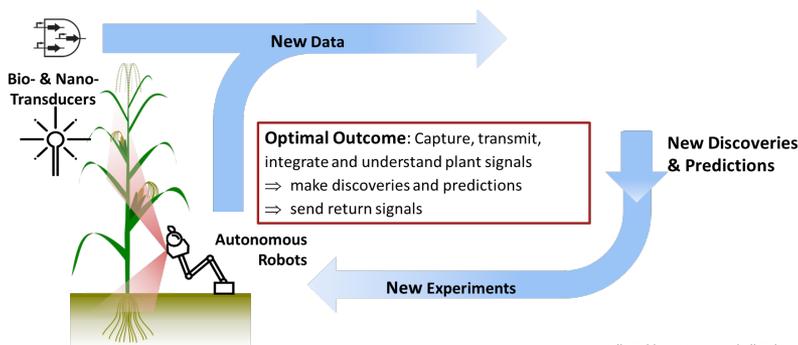
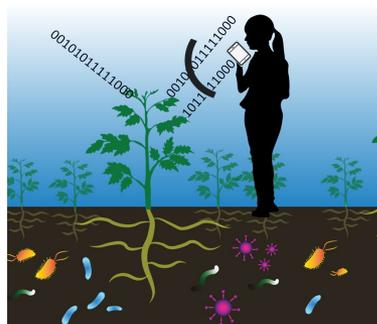


Image: Meagan Lang, Kelly Robbins, Amy Marshall-Colon



Research Community

- Nano-Enabled Internet of Things**

New Equipment Highlights

- **UHV Load Locked Evaporator (Angstrom Eng.)**
 - In-situ ion beam cleaning
 - GLAD (Glancing Angle Deposition) with rotation, and sample heating
- **Savannah Atomic Layer Deposition Sys. (Veeco)**
 - Al, Pt, Pd, and Ru
 - Ozone generator
- **HDP-PECVD System (Plasma Therm)**
 - High density SiO₂, Si₃N₄, a-SiC, and a-Si films at low temperatures
- **Spectroscopic Ellipsometer (Woollam)**
 - Measuring thin film thicknesses and optical constants of multilayer thin film stacks
 - Parallel detection for rapid measurement and full wafer mapping of film properties
- **Dektak Profilometer (Bruker)**
 - 4Å repeatability
 - Can process up to 200mm wafers
 - 3D mapping

